

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

NAKAMOTO et al.

Application No. Unassigned

Art Unit: Unassigned

Filed: July 10, 2003

Examiner: Unassigned

For: CHMEICAL PROCESSOR, CHEMICAL  
PROCESSING METHOD, AND  
METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE

**PRELIMINARY AMENDMENT**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.

*IN THE TITLE:*

Replace the title with:

~~CHEMICAL~~ CHEMICAL PROCESSOR, CHEMICAL PROCESSING METHOD, AND  
METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE